

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L. L. P.

1300 I STREET, N. W.

WASHINGTON, DC 20005-3315

202 • 408 • 4000

FACSIMILE 202 • 408 • 4400

ATLANTA

404 • 653 • 6400

PALO ALTO

650 • 849 • 6600

WRITER'S DIRECT DIAL NUMBER:

(202) 408-4020

September 21, 2000

TOKYO

011 • 813 • 3431 • 6943

BRUSSELS

011 • 322 • 646 • 0353

ATTORNEY DOCKET NO.: 07553.0008

Box Patent Application
Assistant Commissioner for Patents
Washington, D.C. 20231

New U.S. Patent Application

Title: PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD

Inventors: Chishio KOSHIMIZU and Kazunori NAGAHATA

Sir:

We enclose the following papers for filing in the United States Patent and
Trademark Office in connection with the above patent application.

1. A check for \$844 representing a \$804 filing fee and \$40 for recording the Assignment.
2. Application - 27 pages, including 4 independent claims and 22 claims total.
3. Drawings - 5 sheets of formal drawings containing 5 figures.
4. Declaration and Power of Attorney.
5. Recordation Form Cover Sheet and Assignment to Tokyo Electron Limited.
6. Certified copy of Japanese Patent Application No. 11-268578, filed September 22, 1999.

Applicants claim the right to priority based on Japanese Patent Application No.
11-268578, filed September 22, 1999.

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Please accord this application a serial number and filing date and record and return the Assignment to the undersigned.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or § 1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: David W. Hill
David W. Hill
Reg. No. 28,220

DWH/FPD/dvz
Enclosures

001260-0165960